



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q64215

Yoshihiro HAYASHI, et al.

Appln. No.: 09/838,343

Group Art Unit: 2823

Confirmation No.: 1069

Examiner: DANG, Trung Q

Filed: April 20, 2001

For:

METHOD FOR VAPORIZATION OF LIQUID ORGANIC FEEDSTOKK

METHOD FOR GROWTH OF INSULATION FILM

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP NON-FEE AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This Amendment is submitted in response to the Office Action dated March 14, 2003.

Please amend the above-identified application as follows:

IN THE SPECIFICATION:

Pages 12-13, delete the bridging paragraph and insert the following paragraph:

As shown in Fig. 6, a liquid organic monomer 17 stored in a feedstock tank 15 is fed to a feedstock piping 23, and then to an organic monomer vaporization chamber 47 via a liquid mass flow controller 45 at a predetermined rate. On the other hand, a carrier gas 51 is also fed from a carrier gas piping 37 to the organic monomer vaporization chamber 47 via a gas mass flow controller 49. Actually, the timing of feeding the carrier gas and the organic monomer is controlled with solenoid valves (not shown) mounted between the vaporization chamber 47 and